

Notice of References Cited	Application/Control No. 10/694,221	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner John E Chapman	Art Unit 2856	Page 1 of 1

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	B	US-6,006,606	12-1999	Shinogi et al.	73/514.33
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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